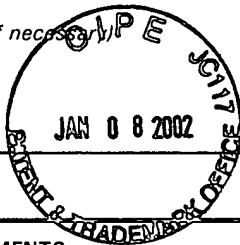


LIST OF REFERENCES CITED BY APPLICANT <i>(Use several sheets if necessary)</i>	ATTY. DOCKET NO.	SERIAL NO.
	595.022-051	09/943,237
	APPLICANT	
	Endisch, et al.	
	FILING DATE	GROUP
	August 29, 2001	20442822



U.S. PATENT DOCUMENTS

*EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
MG	AA	6,146,971	11/14/00	Process for Forming a Shallow Trench Isolation Structure	438	424	01/26/00
MG	BB	6,171,928	01/09/01	Method of Fabricating Shallow Trench Isolation	438	424	09/14/99
	CC						
	DD						
	EE						
	FF						
	GG						
	HH						
	II						

FOREIGN PATENT DOCUMENTS

		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
							YES	NO
	JJ							
	KK							
	LL							
	MM							
	NN							

OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, Etc.)

	OO	
	PP	
	QQ	

EXAMINER	DATE CONSIDERED
Maria Guerrero	4-12-02

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not